

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: M. YAKUSHIJI et al
Serial No.: Not yet assigned
Filed: February 27, 2004
For: PLASMA ETCHING APPARATUS AND PLASMA ETCHING METHOD

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§ 1.97 & 1.98

Mail Stop: PATENT APPLICATIONS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 27, 2004

Sir:

In the matter of the above-identified application, applicants are submitting herewith a copy of the document listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.


This Information Disclosure Statement is being submitted with the new application.

Although the document listed on the attached form is not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by the submission of an English language Abstract attached thereto and by discussion in the Specification, beginning on page 3.

It is respectfully requested that this Information Disclosure Statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper to the deposit account of Antonelli, Terry, Stout & Kraus Deposit Account No. 01-2135 (Case: 648.43545X00), and please credit any excess fees to such deposit account.

Respectfully submitted,
ANTONELLI, TERRY, STOUT & KRAUS, LLP



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Attachments

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Complete if Known		
				Application Number	Not Yet Assigned	
				Filing Date	February 27, 2004	
				First Named Inventor	M. YAKUSHIJI	
				Art Unit		
Examiner Name						
Attorney Docket Number	648.43545X00					
Sheet	1	of	1			

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)				
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FOREIGN PATENT DOCUMENTS							
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)					
		JP 05-275385		10-22-93	Tokyo Electron Yamanashi KK		AB

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard St.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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